



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cécile AULNETTE et al.

Confirmation No.: 7888

Application No: 10/763,978

Group Art Unit: 2814

Filing Date: January 22, 2004

Examiner: L. Pham

For: SEMICONDUCTOR STRUCTURE FOR
PROVIDING STRAINED CRYSTALLINE LAYER ON
INSULATOR AND METHOD FOR FABRICATING
SAME

Atty. Docket No.: 4717-7300

LETTER RE: PRIOR ART

BOX ISSUE FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

The following references have been brought to the attention of the applicants during prosecution of a corresponding application: Chinese patent application 1388589-A (equivalent to US patent application 2002/016708) and Chinese patent application 1364309-A (equivalent to European patent application 1197992 A1). The applicants and their attorneys and representatives have reviewed these references and confirm that they are not material to the patentability of the present claims.

Since the Rules of Practice in Patent cases do not provide for the review of non-material references by the Examiner after a Notice of Allowance has been mailed, it is respectfully requested that these references simply be placed in the file of this application.

Respectfully submitted,


Allan A. Fanucci (Reg. No. 30,256)

Date: 11/17/05

WINSTON & STRAWN LLP
CUSTOMER NO. 28765
(212) 294-3311